

**S/N 09/825,613**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	SUJIT SHARAN ET AL.	Examiner: Asok K Sarkar
Serial No.:	09/825,613	Group Art Unit: 2829
Filed:	April 03, 2001	Docket No.: 303.930US4
Title:	METHOD FOR PECVD DEPOSITION OF SELECTED MATERIAL FILMS	

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**RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

This responds to the Notice of Non-Compliant Amendment mailed on May 10, 2006. In compliance with 37 CFR 1.121, Applicant submits the following corrected section from Applicants' previously-submitted Amendment and Response filed February 22, 2006.